

<b>Notice of References Cited</b>	Application/Control No. 09/728,535	Applicant(s)/Patent Under Reexamination JUNG ET AL.	
	Examiner Cynthia Hamilton	Art Unit 1752	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2003/0108815 A1	06-2003	Jung et al	430/273.1
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Polymer, volume 42, number 1 (January ) 2001 (published September 2000), the table of contents, 2 pages.
	V	www.sciencedirect.com/science?_0...10&md5=bc534c4d63b93087d9e698b9ff3d , "ScienceDirect - Polymer :Amine gradient process for DUV lithography", Polymer, Volume 42, Issue1, January 2001, Abstract page, one page, Date marked available September 7 2000.
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.